

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: S. KADLEC, et al.

Serial No.: 10/798,331

Filed: March 12, 2004

For: METHOD FOR MANUFACTURING SPUTTER-COATED
SUBSTRATES, MAGNETRON SOURCE AND SPUTTERING
CHAMBER WITH SUCH SOURCE

Group: 1795

Examiner: Michael A. Band
Conf. No.: 6134

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

October 16, 2009

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a response within the first month subsequent to expiration of the shortened statutory period set in the outstanding Office Action mailed July 1, 2009. A credit card payment form in the amount of \$130.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (635.43483X00) and excess fees credited to account.

Respectfully submitted,

/Ronald J. Shore/

Ronald J. Shore

Registration No. 28,577

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RJS/kmh
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